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APPLICANTS

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**** CONTINUING DATA ******* *yes A1*
 This application is a DIV of 09/880,932 06/15/2001 ABN

**** FOREIGN APPLICATIONS ******* *yes A1*
 JAPAN 2000-193734 06/28/2000
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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>A1</i>				

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TITLE
 Hexagonal boron nitride film with low dielectric constant, layer dielectric film and method of production thereof, and plasma CVD apparatus